

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: )  
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Shinji MAEKAWA et al. )  
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Serial No.: 10/827,457 )  
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                            )  
Filed: April 19, 2004 )  
                            )  
                            )  
For: Method For Forming Pattern And )  
     Drop Discharge Apparatus )  
                            )  
                            )  
Examiner: Marianne L. Padgett )  
                            )  
                            )  
Art Unit: 1792 )  
                            )  
                            )  
Confirmation No.: 2984 )

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT H (AFTER FINAL)**

Applicants have the following response to the Final Rejection of July 23, 2009, a RCE and a one month extension of time being submitted herewith.

Please amend the above-identified application as follows: